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Docket No.: M4065.0073/P073  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Donald L. Yates

Application No.: 09/123,430

Art Unit: 2823

Filed: July 28, 1998

Examiner: B. Kebede

For: METHOD OF REDUCING SURFACE  
CONTAMINATION IN SEMICONDUCTOR  
WET-PROCESSING VESSELS

**AMENDMENT AFTER FINAL ACTION (37 C.F.R. § 1.116)**

MS AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated January 30, 2004 (Paper No. 20040122), finally rejecting claims 1, 6, 7, 9, 10, 15, 22, 25, 44, 61-64, 66, and 67, please amend the above-identified U.S. patent application as follows:

**Amendments to the Specification** are shown beginning on page 3 of this paper.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 5 of this paper.

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**Remarks/Arguments** begin on page 19 of this paper.